

ATTORNEY DOCKET
064747.1017

PATENT APPLICATION
10/825,021

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Shannon V. Davidson et al.
Serial No.: 10/825,021
Filing Date: April 15, 2004
Group Art Unit: 2191
Confirmation No.: 7500
Title: *System and Method for Topology-Aware Job Scheduling and Backfilling in an HPC Environment*

Mail Stop: Amendments

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

Information Disclosure Statement

Applicants submit this Information Disclosure Statement (IDS) under 37 C.F.R. § 1.97(b)(3). Applicants respectfully request the Examiner to consider and cite in the examination of this Application the documents listed in the attached Form PTO-1449. Under 37 C.F.R. § 1.98(a)(2)(ii), Applicants have provided copies of all references other than U.S. patents and U.S. patent application publications.

The Commissioner is hereby authorized to charge any fee and credit any overpayment to Deposit Account No. 02-0384 of Baker Botts L.L.P.

Respectfully submitted,
BAKER BOTTS L.L.P.
Attorneys for Applicants



Travis W. Thomas
Reg. No. 48,667

Date: March 2, 2007

Correspondence Address:

Customer Number 45507

PTO-1449 Information Disclosure Citation In an Application		Application No. 10/825,021		Applicant(s) Shannon V. Davidson et al.	
		Docket Number 064747.1017	Group Art Unit 2191	Filing Date April 15, 2004	
U.S. PATENT DOCUMENTS					
		DOCUMENT NO.	DATE	NAME	CLASS
FOREIGN PATENT DOCUMENTS					
		DOCUMENT NO.	DATE	COUNTRY	CLASS
					SUBCLASS
					TRANSLATION
					YES
					NO
NON-PATENT DOCUMENTS					
		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)			DATE
	A	Hans-Ulrich Heiss, "Processor Management in Two-Dimensional Grid-Architectures," Interner Bericht Nr. 20/92, XP002416087, 51 pages			December 1992
	B	EPO Registered Letter, Application No. 05 252 239.8-1243, 6 pages			Mailed 02/02/2007
	C				
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	I				
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	M				
EXAMINER				DATE CONSIDERED	
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.					

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